



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Daisuke KOMADA, et al.**

Group Art Unit: 1756

Serial No.: 10/058,426

Examiner: **BARRECA, Nicole M.**

Filed: **January 30, 2002**

Confirmation No.: 4298

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING SILICON CARBIDE FILM**

Attorney Docket No.: 020060

Customer Number: 38834

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: September 1, 2004

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 1, 2004 for a second month from August 1, 2004 to September 1, 2004 (a one month extension of time having already been filed on July 20, 2004).

Attached please find a check in the amount of \$310.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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